



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Hiroshi MORIOKA**

Art Unit: 1795

Application Number: **10/692,722**

Examiner: **Daborah Chacko-Davis**

Filed: **October 27, 2003**

Confirmation Number: **9699**

For: **MICRO PATTERN FORMING METHOD AND SEMICONDUCTOR DEVICE  
MANUFACTURING METHOD**

Attorney Docket Number: **032045**

Customer Number: **38834**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

August 12, 2008

Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated February 13, 2008 for three months from May 13, 2008 to August 13, 2008 (a two months extension of time was previously paid on July 14, 2008).

Attached please find a check including the amount of \$590.00 for the cost of the extension of time. If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**

Michael J. Caridi

Attorney for Applicant

Registration No. 56,171

Telephone: (202) 822-1100

Facsimile: (202) 822-1111

08/13/2008 MAHME1 00000042 10692722

02 FC:1253

590.00 OP

MJC/ttw